IN THE SPECIFICATION:

Please amend paragraph beginning on page 4 line 3 as follows:

There has heretofore been proposed a process for conducting microworking by irradiating a formed PTFE material with an ultraviolet laser beam [for example, S. Wada et al. Appl. Phys. Lett.-63, 211-(1993) 62 (3), 211 (1993)]. It is however extremely difficult to apply this process to the perforation of the stretched porous PTFE material. When the stretched porous PTFE material is irradiated with an ultraviolet laser beam, not only a microhole is formed by chemical and physical breaking, decomposition, cutting and evaporation, but also the fibrils are fused by heat generated by the irradiation of the laser beam to collapse a peripheral microporous structure including a wall surface of the microhole, so that the properties inherent in the stretched porous PTFE material are impaired.